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PATENT & TRADEMARK OFFICE

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on January 5, 2005.

E. R. Witt  
Attorney for Applicants

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/614,465  
Applicant : Tehsin Lee et al.  
Title : METHOD AND SYSTEM FOR POST-TREATING DRY-ETCHED METAL FILM  
Filed : July 7, 2003  
TC/A.U. : (not yet assigned)  
Examiner : (not yet assigned)  
Docket No. : 3304.2.66  
Customer No. : 21552

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

STATUS INQUIRY

Dear Sir:

In view of the fact that no action has been taken on this case since it was initially filed on July 7, 2003, Applicant respectfully requests a report concerning the status of the above-identified application.

Respectfully submitted,

E. R. Witt  
Evan R. Witt  
Reg. No. 32,512  
Attorney for Applicants

Date: January 5, 2005

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